







an Open Access Journal by MDPI

# Advanced Micro/Nano Manufacturing Technologies for Biomedical Microsystems

Guest Editor:

#### Dr. Colin Dalton

Electrical and Software Engineering Department, University of Calgary, Calgary, AB T2N 1N4, Canada

Deadline for manuscript submissions:

closed (30 April 2023)

# **Message from the Guest Editor**

Dear Colleagues,

The focus of this Special Issue will be on advancements in micro/nanomanufacturing technologies for biomedical micro-systems. Topics will include fundamental materials science, traditional manufacturing processes such as photolithography, emerging micro-additive/hybrid technologies such as multimaterial 3D printing, MEMS and NEMS applications, miniaturized robotic systems, and nanomaterials for biosensing.

Application areas cover microfluidic/lab-on-a-chip systems for areas such as diagnostics; miniaturized drug delivery systems such as microneedles; materials for neural prosthetics, implants, and scaffolds; and minimally invasive surgical applications and tissue engineering.













an Open Access Journal by MDPI

## **Editor-in-Chief**

# **Message from the Editor-in-Chief**

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

## **Author Benefits**

**Open Access:** free for readers, with article processing charges (APC) paid by authors or their institutions.

 $\textbf{High Visibility:} \ indexed \ within Scopus, SCIE \ (Web \ of \ Science), \ PubMed,$ 

PMC, Ei Compendex, dblp, and other databases.

Journal Rank: JCR - Q2 (Chemistry, Analytical) / CiteScore - Q2 (Mechanical

Engineering)

### **Contact Us**